

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: ODA, et al.

Serial No.: Not yet assigned

Filed: March 2, 2004

For: SEMICONDUCTOR DEVICE, SEMICONDUCTOR CIRCUIT MODULE  
AND MANUFACTURING METHOD OF THE SAME

**INFORMATION DISCLOSURE STATEMENT**  
**UNDER 37 CFR 1.97 & 1.98**

Mail Stop DD  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

520.43558X00

Sir:

In the matter of the above-identified application, applicants are submitting herewith a copy of the documents listed in the attached form equivalent to Form PTO-1449 for the Examiner's consideration.

This information disclosure statement is being submitted with the new application.

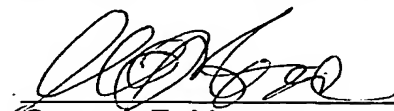
Although some of the documents listed on the attached form equivalent to Form PTO-1449 are not in the English language, the requirement of 37 CFR 1.98(a)(3) for a concise explanation of the relevance is satisfied by the attached English language abstracts, or the discussion of the documents in the specification, for example, on page three (3).

It is respectfully requested that this information disclosure statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli, Terry, Stout & Kraus Deposit Account No. 01-2135 (Case: 520.43558X00), and please credit any excess fees to such deposit account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS LLP



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Gregory E. Montone  
Registration No. 28,141

<b>Form PTO-1449</b>	<b>U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE</b>	<b>ATTY. DKT. NO.</b> 520.43558X00	<b>SERIAL NO.</b>
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Use several sheets if necessary)		<b>APPLICANT</b> ODA, et al.	
		<b>FILING DATE</b> March 2, 2004	<b>GROUP</b>

**U.S. PATENT DOCUMENTS**

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date
	AA					
	AB					
	AC					
	AD					
	AE					
	AF					
	AG					
	AH					
	AI					
	AJ					
	AK					
	AL					

**FOREIGN PATENT DOCUMENTS**

Examiner Initial	Document Number	Date	Country	Class	Subclass	Abstract	
						Yes	No
	AM	9-283533	10/31/1997	JP	H01L	21/331	X
	AN	2798576	07/03/1998	JP	H01L	21/205	X
	AO						
	AP						
	AQ						
	AR						
	AS						
	AT						

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

	AU	J. Kouvetakis, et al., "Novel Chemical Routes to Silicon-Germanium-Carbon Materials", Appl. Phys. Lett., Vol. 65, No. 23, December 5, 1994, Pgs. 2960-2962
	AV	
	AW	
	AX	
	AY	
	AZ	
<b>Examiner</b>		<b>Date Considered</b>